

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: K. OHNISHI et al.
Serial No.: (New Divisional application under 37 CFR §1.53[b] of U.S.
Application Serial No. 09/829,969)
Filed: On even date herewith
For: SEMICONDUCTOR DEVICE AND PROCESS FOR
PRODUCING THE SAME
Group: 2818
Examiner: M. TRAN

CLAIM FOR FOREIGN PRIORITY

MS: PATENT APPLICATIONS

Commissioner for Patents
POB 1450
Alexandria, VA 22313-1450

March 31, 2004

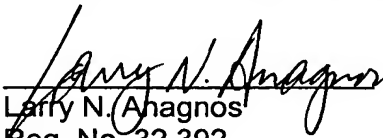
Sir:

Pursuant to 35 U.S.C. §119 and 37 CFR §1.55, applicants hereby claim
the right of priority based on the following foreign application filed in Japan:

Application No. 2000-118491, filed April 14, 2000.

A certified copy of this foreign application was filed on May 23, 2001
in U. S. application Serial No. 09/829,969, filed on April 11, 2001.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP


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